

ABSTRACT OF THE DISCLOSURE

Provided are a liquid-jet head in which a passage-forming substrate and a nozzle plate can be suitably joined, a method of manufacturing the same, and a liquid-jet apparatus. A covering plate has a piezoelectric element holding portion which covers piezoelectric elements. This covering plate is joined with a side of the passage-forming substrate where the piezoelectric elements are provided. At the same time, the nozzle plate provided with nozzle orifices is joined with a side of the passage-forming substrate opposite the side where the covering plate is joined. Moreover, at least a region of the passage-forming substrate facing the piezoelectric element holding portion is formed to be relatively thicker than the outside of the region facing the piezoelectric element holding portion.